

Quantifying the thickness of magnetically active layers using x-ray resonant magnetic scattering

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X-ray resonant magnetic scattering measurements below and above the critical angle for total external reflection allow fitting to extract the magnetically active volume within specific magnetic layers. Uncapped ultrathin Co films deposited onto Ni on Si display more magnetic resonant response than do those grown directly onto the native oxide of Si. © 2004 American Institute of Physics. [DOI: 10.1063/1.1667868]

Advances in magnetic storage and spin-based electronics require a thorough understanding of ferromagnetic–ferromagnetic and ferromagnetic–nonmagnetic interfaces. A ferromagnetic interface is a chemical boundary that may also serve as a magnetic boundary, delineating the magnetically active region of a layer.¹ Recently, using diffuse soft-x-ray resonant magnetic scattering, (XRMS) or diffuse XRMS, we showed that the charge and magnetic morphologies are correlated for a Fe/Co interface.² At a vacuum/Co or an Al/Co interface, the magnetic boundary differed in morphology from the charge interface. There is a region within the magnetic thin film that does not respond to an applied alternating magnetic field. The diffuse XRMS measurement quantified the morphology of the boundaries, but could not be used to specify the volume of the active magnetic layer, even where charge and magnetic morphologies are correlated. Information on the thickness of the magnetically active part of the magnetic thin film (and correspondingly the thicknesses of the nonactive parts) may be obtained through specular XRMS.

Following a report of a magnetically “dead” layer by Liebermann *et al.*³ in 1970 using Mössbauer spectroscopy, several techniques for measuring the thickness of nonmagnetic layers within nominally ferromagnetic films have been developed. These dead layers occur at the interfaces and may be thought of as transition layers between a foreign material interface and the magnetically active region. Therefore, surface-sensitive techniques are desired for measuring these layers. Some techniques, such as vibrating sample magnetometry,⁴ yield the active magnetic volume of the film but cannot separate surface from bulk properties. Scattering techniques are more sensitive to the interfaces of the film. Neutron scattering is an established and powerful tool for determining transition layers,^{5,6} but, due to weak signals, this technique is best suited for studying multilayer structures with Bragg reflections. Soft x-ray techniques, such as x-ray

magnetic circular dichroism (XMCD)⁷ and XRMS are best suited for measuring the transition layer for individual layers of transition metals. Similar in form to neutron reflectivity,⁸ XRMS has the added advantage of yielding structural information through the angular dependence of the scattered intensity.⁹ Also, XRMS is a photon in/photon out process, allowing measurements under applied magnetic fields¹⁰ unlike XMCD, which employs electrons for readout. The element-specific resonance at absorption edges also allows probing of one ferromagnetic element in the close proximity of a second ferromagnetic element.

Most reported measurements of XRMS are spectroscopic, measuring the resonant reflectivity as a function of incident photon energy. We follow the treatment of Raoux¹¹ in measuring XRMS as a function of incident angle. Although total external reflection makes the relationship between probed depth and incident angle nonlinear, magnetic depth profiling may be possible using angularly dependent XRMS. To test this, three Co films ranging in thickness from 13 to 29 Å (Table I) were deposited onto the native oxide of Si wafers, using dc magnetron sputtering at 2.0 mTorr Ar pressure in a UHV chamber with $\sim 1 \times 10^{-9}$ Torr. To study further the effect of an adjoining ferromagnetic film on the Co, three more Co films of approximately the same thickness were deposited onto ~ 15 Å of Ni.

The samples are transferred without breaking the vacuum to a diffractometer chamber at the Synchrotron Radiation Center of the University of Wisconsin–Madison.¹² For our XRMS measurements, we used a beamline with a C/W multilayer mirror monochromator that delivers $\sim 6 \times 10^8$ elliptically polarized photons/s to the sample at ~ 775 eV, the L_2 edge of Co. The energy resolution, $\Delta\lambda/\lambda$, is 4%, or approximately 30 eV at 775 eV. Experiments were performed at $E \sim 787$ eV as required by the aforementioned 4% energy resolution of the system. As the magnetically dependent dispersive optical constant, δ_m , changes sign between the edges, it was valuable to reduce the influence of

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TABLE I. Surface roughness σ_{surface} , coercivity H_c , top and bottom dead layers Δ_{top} and Δ_{bottom} , total nonmagnetic thickness Δ_{total} , active layer thickness d_{active} for Co sputter-deposited films, and asymmetry ratio above the critical angle for total external reflection. All thickness measurements determined by soft-x-ray fitting. Errors determined by confidence bars as in Fig. 2.

Ferromagnetic layer $\pm d^{\text{err}}$	Substrate	σ_{surface} (Å)	H_c (Oe)	Δ_{top} (Å)	Δ_{bottom} (Å)	Δ_{total} (Å)	d_{active} (Å)	AR(%) $\theta @ 3^\circ$
(13 Å Co ± 2)	Si	4	N/A			12.5 total	0.5 \pm 0.5	1
(13.5 Å Co ± 4)	14 Å Ni/Si	8	21	0.5	6.0	6.5	7.0 \pm 2.0	9
(16 Å Co ± 2)	Si	2	11	0.5	11.5	12.0	4.0 \pm 1.5	7
(27 Å Co ± 4)	14 Å Ni/Si	9	5	4.0	9.0	13.0	14.0 \pm 4.0	12
(29 Å Co ± 3)	Si	9	35	7.5	14.0	21.5	7.5 \pm 2.5	7
(40 Å Co ± 7)	14 Å Ni/Si	12	11	10.0	7.5	17.5	22.5 \pm 5.0	13

the L_3 edge at 778 eV and increase the contribution of the L_2 edge at 793 eV.

We measure the scattered x rays as a function of the incident angle θ and detector angle 2θ (Fig. 1) to obtain the specularly reflected intensity. We augment this θ - 2θ scan with fixed-detector rocking curves at each detector position 2θ to help our custom-built diffractometer maintain synchronization with the reflection and provides background scattering information at the scan extrema. In addition to the XRMS measurements, we obtain element specific hysteresis curves using the XRMS specular reflection to determine the coercive force and magnetic quality of the films. These scans are done at a fixed $\theta = 3^\circ$ angle of incidence, maximizing reflectance by staying just off the regime of total external reflection.

We magnetize the sample with an electromagnet that can deliver a maximum field of ~ 64 G without outgassing into the vacuum chamber, either parallel or antiparallel to the photon helicity. We generally use fields of ~ 55 G, which is greater than the coercive field of our samples. We measure the scattered intensity point by point for magnetization parallel and antiparallel to the photon helicity, called I_+ and I_- , respectively. We then calculate the difference intensity, $\Delta I(\mathbf{M}, \Omega) = I_+ - I_-$, and the sum intensity, $I_{\text{ave}}(\theta) = (1/2) \times (I_+ + I_-)$. A scan from a demagnetized sample would have an intensity of $(1/2)(I_+ + I_-)$, i.e., between a full scan taken with magnetization parallel to the photon helicity, and a scan taken with the magnetization antiparallel. $\Delta I(\mathbf{M}, \theta)$ and $I_{\text{ave}}(\theta)$ are then divided by the initial incident intensity at $\theta = 0$, yielding the a nonresonant reflectivity, R , and a resonant difference reflectivity, ΔR .

We use the reflectivity and difference reflectivity to measure the asymmetry ratio, the intensity when the sample is magnetized in one direction minus the intensity when the sample is magnetized in the opposite direction, divided by their average. Its value for a given element depends on the relative number of moments that follow the applied field. In

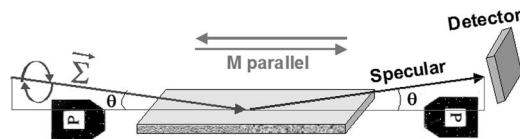


FIG. 1. Scattering geometry for specular XRMS measurements. At every detector angle 2θ , we measure a rocking curve. We correct for the background using points away from the specular reflection.

the limit that a film is nonmagnetic or for some reason non-responsive, the asymmetry ratio is zero, i.e., there is no change in intensity when the direction of the field is reversed. Values for the asymmetry ratio at $\theta = 3^\circ$ are also given in Table I.

Element-specific hysteresis curves (not shown) of the bare-Co/Si film yield a nearly square hysteresis loop, indicating a single-domain sample, and a coercive field of about 11 G. The Co/Ni/Si film shows lower squareness and may have multiple domains. It has a coercive field of about 5 G. The low coercivity values indicate that the films have a low defect density, since lower coercivity generally indicates fewer pinning centers for magnetic domains.¹³ Coercivities for all samples may be found in Table I.

The reflectivity and difference reflectivity were fitted to obtain the active and transition layer thicknesses. Calculations were performed using the recursive matrix algorithm code for resonant reflectivity of Lee *et al.*¹⁴ We interpolated nonresonant optical constants from the tables of Henke *et al.*¹⁵ and resonant optical constants from Mertins *et al.*,¹⁶ multiplying the latter by 0.70 to approximate the incomplete circular polarization expected from synchrotron radiation. Although this code allows a full treatment of resonant and nonresonant contributions and their interactions with the circularly polarized beam, we chose to simplify modeling by

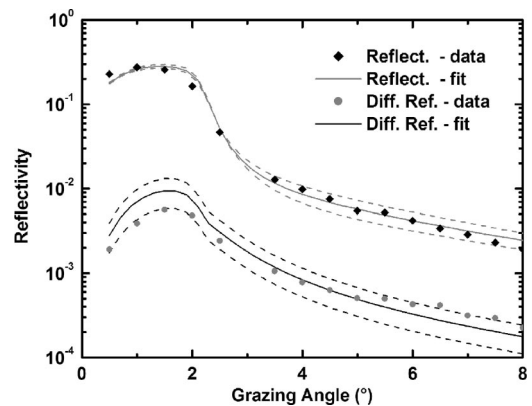


FIG. 2. Example of reflectivity and difference reflectivity fits for the 16 Å Co film on Si. Dashed lines represent the ± 2 Å uncertainty in the reflectivity fit and the corresponding ± 1.5 Å uncertainty in the difference reflectivity fit. The finite beam width and finite sample height are included in the fit to correct discrepancies at small angles above the critical angle for total external reflection. See Table I for values.

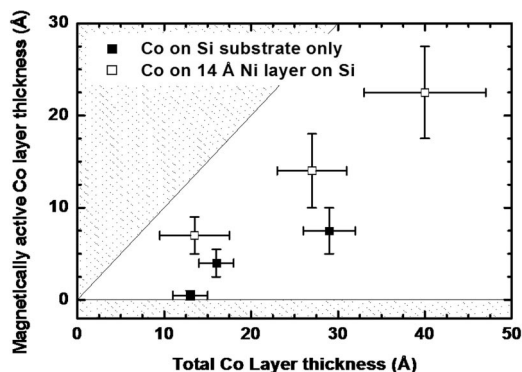


FIG. 3. Comparison between the active magnetic-layer thickness and the total magnetic-layer thickness for Co on Si and Co on Ni/Si. The shaded regions are not physical. The difference reflectivity from the 13 Å Co film on Si was negligible. The Co films on Ni exhibited more element-specific difference reflectivity than did the Co films on Si, possibly due to the reinforcement of the easy in-plane axis by the Ni.

folding all magneto-optical effects into an extra term in the index of refraction,⁶

$$n_{\pm} = 1 - (\delta \pm \Delta\delta) + i(\beta \pm \Delta\beta), \quad (1)$$

where δ , β are the nonresonant dispersive and absorptive components of the index of refraction, and $\Delta\delta$, $\Delta\beta$ are the resonant dispersive and absorptive terms, which change sign with the direction of the applied field. Our rationale is that our stated energy resolution, $\Delta\lambda/\lambda$, 4%, necessitates numerically integrating fits over a range of energies near the L_2 edge, complicating our fitting. An example fit to the data, with dotted lines to represent confidence intervals, is shown in Fig. 2. The fits are optimized for the angular region at and just past the critical angle for total external reflection. Fit results are summarized also in Table I.

Figure 3 shows the full results of the fitting of the magnetically active Co film thickness as a function of total Co film thickness for both types of substrates. We can clearly resolve that the addition of Ni as an underlayer to thin Co films makes the apparent Co magnetic volume increase and the Co transition layer thickness decrease. A previous study of evaporated Co on Si(111)¹⁷ showed that 3 monolayer (ML) thick films of Co were nonmagnetic, and that films 3 ML to 9 ML in thickness were magnetic with the easy axis canted away from the sample plane. The apparent increase in ferromagnetic volume relative to Co-on-Si due to the Ni underlayer may be due to the Ni changing the angle of the canting more toward an easy in-plane axis. As XRMS measures only in-plane spins, any tilting toward the sample plane would increase the resonant scattering. Even if the Ni does not change the orientation of the magnetically active spins,

the Ni may provide coordination to nominally uncoordinated Co spins at the interface. Other explanations are also possible, e.g., differing amounts of intermixing between Co/Ni and Co/Si. This element-specific measurement includes the effect of the Ni on the Co, without including any resonant contribution from the Ni itself.

Soft-x-ray angular-dependent XRMS is an effective tool for measuring the in-plane magnetization of thin ferromagnetic films. The in-plane magnetization of 10–30 Å thick Co on Si was less than that for similar depositions of Co on ~15 Å of Ni. The fitting indicates that the Co/Si interface creates a larger magnetic transition layer than Co/Ni or vacuum/Co interfaces. The element-specific nature of XRMS allows quantification of the active volume within the Co layer and holds promise as an in-plane magnetic-depth profile tool, and as a complementary tool to absorption techniques, such as XMCD, that may be performed out of plane.

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